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Sandra K. Lawrence

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Type of Paper transmitted: Comments on Statement of Reasons for Allowance

Applicant's Name: Fumikatsu UESAWA

Serial No. (Control No.): 10/720,851

Examiner: SMOOT, Stephen W.

Filing Date

November 24, 2003

Art Unit: 2813

Application Title:

METHOD OF MANUFACTURING A SEMICONDUCTOR
APPARATUS WITH A TAPERED APERTURE PATTERN TO FORM
A PREDETERMINED LINE WIDTH

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Fumikatsu UESAWA) Group Art Unit: 2813
Serial No.: 10/720,851) Examiner: SMOOT, Stephen W.
Filed: November 24, 2003)
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR APPARATUS WITH)
A TAPERED APERTURE PATTERN TO)
FORM A PREDETERMINED LINE WIDTH)

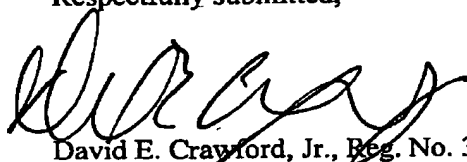
Assistant Commissioner for Patents
Washington, DC 20231

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Although the Examiner's statement of reasons for allowance is factually correct, Applicants believe the Examiner's statement does not set forth all the distinctions between the claims of the present application and the prior art.

June **22**, 2005

Respectfully submitted,



David E. Crawford, Jr., Reg. No. 38,118
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